## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Mattew Angyal et al Examiner: Prashant J. Khatri

Serial No.: 10/597,038 Group Art Unit: 1794

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Title: GRADIANT DEPOSITION OF LOW-K CVD MATERIALS

Confirmation: 5103

## **AMENDMENT AND RESPONSE**

Mail Stop Non-Fee Amendment Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to an Office Action mailed July 23, 2009 by the United States Patent and Trademark Office in connection with the above-identified Application. A response to the July 23, 2009 Office Action is due by October 23, 2009. Therefore, this response is being timely filed.

Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.